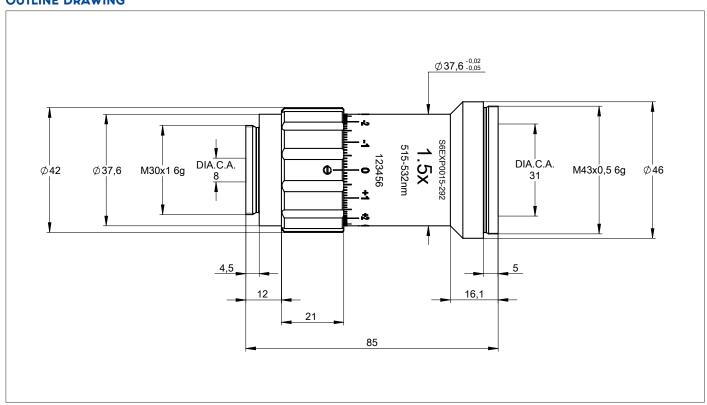
DATA SHEET

S6EXPO015-292

BEAMEXPANDER MAGNIFICATION 1.5 FOR 515 - 545 nm FUSED SILICA



OUTLINE DRAWING



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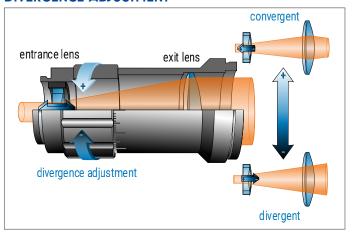


DATA SHEET

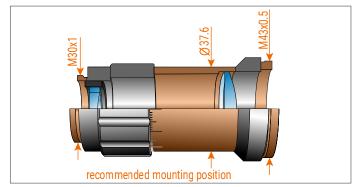
SPECIFICATIONS

article number	S6EXP0015-292
design wavelength [nm]	532
magnification factor	1.5
divergence adjustable	yes
optical principle	Galilei (no internal focus)
pointing stability [mrad]	<1
clear input aperture [mm]	8.0
clear output aperture [mm]	31.0
recommended beam-Ø [mm]1)	6.0
total number of lenses	3
total transmission [%]	> 98
lens material	fused silica
LIDT (coating) [J/cm²]	2.5 J/cm² per 1ns pulse at 50Hz
SP and USP usable	yes
SP and USP usable, reversed usage	no
mounting thread	M30x1
weight [kg]	0.2
accessory	S6MEC0107 - adapter M30x1 to C-mount

DIVERGENCE ADJUSTMENT



MOUNTING POSITIONS



REMARKS

¹⁾clipped at $1/e^2$; wavefront error on axis (PV) < $\lambda/10$ (value provided by design) magnification (reversed mode) = 1 / magnification (regular mode)

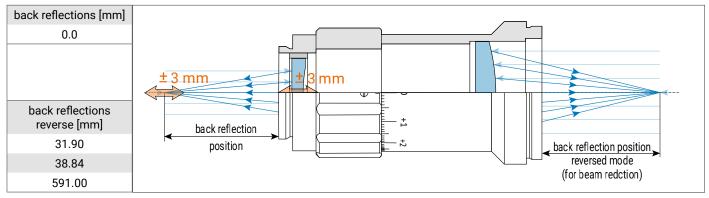
divergence adjustement = 0 → collimated input beam results in collimated output beam

maximum divergence adjustment is ± 3 mm

RoHS compliant

length at divergence setting "0" stated in the drawing - length extension of max. 3 mm is possible

BACK REFLECTION POSITION



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